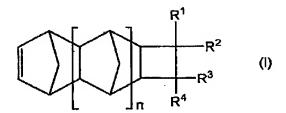
Amendments to Claims

- (Currently amended) A polymer copolymer comprising a repeat unit derived from
 - (a)at least one repeat unit derived from an ethylenically unsaturated compound having at least one fluorine atom covalently attached to an ethylenically unsaturated carbon atom; and
 - (b)at least one repeat unit derived from an ethylenically unsaturated compound having the structure:



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wherein n is 0, 1, or 2;

R¹, R², R³ and R⁴ are independently H, OR⁵, halogen, alkyl or alkoxy of 1 to 10 carbon atoms, optionally substituted by halogen or ether oxygens, Y, C(R_f)(R_f')OR⁵, R⁶Y or OR⁶Y;

Y is COZ or SO₂Z;

R5 is hydrogen or an acid-labile protecting group;

 R_f and R_f are the same or different fluoroalkyl groups of 1 to 10 carbon atoms or taken together are $(CF_2)_m$ where m is 2 to 10;

R⁶ is an alkylene group of 1 to 20 carbon atoms, optionally substituted by halogen or ether oxygen;

Z is OH, halogen, or OR7; and

 R^7 is an alkyl group of 1 to 20 carbon atoms, with the proviso that at least one of R^1 , R^2 , R^3 and R^4 is Y, OR^5 , $C(R_f)(R_f^*)OR^5$, R^6 Y or OR^6 Y, and the proviso that if R^1 (or R^3) is OH, R^2 (or R^4) is not OH or halogen.

2. (Currently amended) The polymer copolymer of Claim 1, wherein the compound having structure (I) is selected from the group consisting of:

wherein R12 is an alkyl group of 1 to 20 carbon atoms.

3. (Currently amended) The polymer copolymer of Claim 1, 10 wherein the at least one ethylenically unsaturated compound having at least one fluorine atom covalently attached to an ethylenically unsaturated carbon atom is a fluoroolefin which comprises 2 to 20 carbon atoms.

- 4. (Currently amended) The polymer copolymer of Claim 3, wherein the fluoroolefin is selected from the group consisting of tetrafluoroethylene; hexafluoropropylene; chlorotrifluoroethylene; vinylidene fluoride; vinyl fluoride; perfluoro-(2,2-dimethyl-1,3-dioxole); perfluoro-(2-methylene-4-methyl-1,3-dioxolane); CF2=CFO(CF2)tCF=CF2, wherein t is 1 or 2; and Rf"OCF=CF2 wherein Rf" is a saturated fluoroalkyl group of from 1 to 10 carbon atoms. 10
 - (Currently amended) The polymer copolymer of Claim 4, wherein the fluoroolefin is tetrafluoroethylene.
- (Currently amended) The polymer copolymer of Claim 1, further 15 comprising a unit containing a fluoroalcohol group or a protected fluoroalcohol group.
- 7. (Currently amended) The polymer copolymer of Claim 6, wherein the fluoroalcohol group or the protected fluoroalcohol group is 20 derived from at least one ethylenically unsaturated compound containing a fluoroalcohol group having the structure:

$-C(R_f)(R_f')OH$

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wherein Rf and Rf are the same or different fluoroalkyl groups of from 1 to 10 carbon atoms or taken together are (CF₂)_m wherein m is 2 to 10.

- 8. (Currently amended) The polymer copolymer of Claim 7, wherein R_f and R_f are perfluoroalkyl groups.
 - (Currently amended) The polymer copolymer of Claim 1, further comprising a unit containing a fluoroalcohol group having the structure:

-XCH2C(Rf)(Rf')OH

wherein R_f and R_f are the same or different fluoroalkyl groups of from 1 to 10 carbon atoms or taken together are (CF₂)_m wherein m is 2 to 10; and X is an element from Group VA or Group VIA of the Periodic Table of the Elements.

- 10. (Currently amended) The polymer copolymer of Claim 9,
 wherein X is selected from the group consisting of oxygen, sulfur, nitrogen and phosphorous.
 - 11. (Currently amended) The polymer copolymer of Claim 10, wherein X is oxygen.

12. (Currently amended) The polymer copolymer of Claim 7, wherein fluoroalcohol group or the protected fluoroalcohol group is derived from a monomer selected from the group consisting of:

$$\mathsf{CH_2C}(\mathsf{CF_3})_2\mathsf{OH} \\ \mathsf{CH_2C}(\mathsf{CF_3})_2\mathsf{OH} \\ \mathsf{CH_2C}(\mathsf{CF_3})_2$$

20 CH₂=CHOCH₂CH₂CCH₂C(CF₃)₂OH CH₂=CHO(CH₂)₄OCH₂C(CF₃)₂OH

13. (Currently amended) The polymer copolymer of Claim 1 further comprising at least one acid-containing or protected acid-containing group of structural unit:

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$$(--CH_2--\overset{E_1}{\overset{E_2}{\overset{E_2}{\overset{E_2}{\overset{E_2}{\overset{E_1}{\overset{E_2}{\overset{E_1}{\overset{E_2}{\overset{E_2}{\overset{E_2}{\overset{E_1}{\overset{E_2}{\overset{E_2}{\overset{E_1}{\overset{E_2}{\overset{E_1}{\overset{E_2}{\overset{E_1}{\overset{E_2}{\overset{E_1}{\overset{E_2}}{\overset{E_2}{\overset{E_2}{\overset{E_2}{\overset{E_2}}{\overset{E_2}{\overset{E_2}{\overset{E_2}{\overset{E_2}}{\overset{E_2}}{\overset{E_2}{\overset{E_2}{\overset{E_2}}{\overset{E_2}{\overset{E_2}{\overset{E_2}{\overset{E_2}}{\overset{E_2}}{\overset{E_2}}{\overset{E_2}}{\overset{E_2}}{\overset{E_2}}{\overset{E_2}}{\overset{E_2}}}}}}}}}}}}}}}}}}}}}$$

wherein E_1 is H or C_1 - C_{12} alkyl; E_2 is CO_2E_3 , SO_3E , or other acidic group; and E and E_3 are independently selected from the group of H, unsubstituted C_1 - C_{12} alkyl, and heteroatom substituted C_1 - C_{12} alkyl.

14. (Currently amended) The polymer copolymer of Claim 13, wherein the heteroatom is selected from the group consisting of oxygen, nitrogen, sulfur, halogen and phosphorus atoms.

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15. (Currently amended) The polymer copolymer of Claim 14, wherein the heteroatom is oxygen, and the heteroatom substituted C_1 - C_{12} alkyl further comprises a hydroxyl group.

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16. (Currently amended) The polymer copolymer of Claim 13, wherein the acid-containing or protected acid-containing group is derived from a carboxylic acid-containing monomer.

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17. (Currently amended) The polymer copolymer of Claim 13, wherein the acid-containing or protected acid-containing group is derived from a monomer selected from the group consisting of tert-butyl acrylate; 2-methyl-2-adamantyl acrylate; 2-methyl-2-norbornyl acrylate and acrylic

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acid.

18. (Currently amended) The polymer copolymer of Claim 1, further comprising at least one group derived from a polar monomer.

- 19. (Currently amended) A photoresist composition comprising:
 - (1) a fluorine-containing polymer copolymer, wherein the fluorine-containing polymer copolymer comprises:
 - (a) at least one repeat unit derived from an ethylenically unsaturated compound having at least one fluorine atom covalently attached to an ethylenically unsaturated carbon atom; and
 - (b) at least one repeat unit derived from an ethylenically unsaturated compound having the structure:

wherein n is 0, 1, or 2;

 R^1 , R^2 , R^3 and R^4 are independently H, OR^5 , halogen, alkyl or alkoxy of 1 to 10 carbon atoms, optionally substituted by halogen or ether oxygens, Y, $C(R_f)(R_f^*)OR^5$, R^6Y or OR^6Y ;

Y is COZ or SO₂Z;

R⁵ is hydrogen or an acid-labile protecting group;

 R_f and R_f are the same or different fluoroalkyl groups of 1 to 10 carbon atoms or taken together are $(CF_2)_m$ where m is 2 to 10;

R⁶ is an alkylene group of 1 to 20 carbon atoms, optionally substituted by halogen or ether oxygen;

Z is OH, halogen, or OR7; and

 R^7 is an alkyl group of 1 to 20 carbon atoms, with the proviso that at least one of R^1 , R^2 , R^3 and R^4 is OR^5 , Y, $C(R_f)(R_f^4)OR^5$, R^6 Y or OR^6 Y, and the proviso that if R^1 (or R^3) is OH, R^2 (or R^4) is not OH or halogen; and

(2) a photoactive component.

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20. (Currently amended) The photoresist composition of Claim 19, wherein the monomer having structure (I) in the fluorine-containing polymer copolymer is selected from the group consisting of:

5 -CO₂R¹² CO2R12 O(CF2)2SO2F C(CF₃)₂OCH₂OCH₃ — CO₂R¹² C(CF₃)₂OH C(CF₃)₂OH C(CF₃)₂OH -OH

wherein R12 is an alkyl group of 1 to 20 carbon atoms.

- 22. (Original) The photoresist composition of Claim 21, wherein the fluoroolefin is selected from the group consisting of tetrafluoroethylene; hexafluoropropylene; chlorotrifluoroethylene; vinylidene fluoride; vinyl fluoride; perfluoro-(2,2-dimethyl-1,3-dioxole); perfluoro-(2-methylene-4-methyl-1,3-dioxolane); CF₂=CFO(CF₂)_tCF=CF₂, wherein t is 1 or 2; and R_f"OCF=CF₂, wherein R_f" is a saturated fluoroalkyl group of from 1 to 10 carbon atoms.
 - 23. (Original) The photoresist composition of Claim 22, wherein the fluoroolefin is tetrafluoroethylene.
- 24. (Currently amended) The photoresist composition of Claim 19, wherein the fluorine-containing polymer copolymer further comprises a unit containing a fluoroalcohol group or a protected fluoroalcohol group.
- 25. (Original) The photoresist composition of Claim 24, wherein the fluoroalcohol group or the protected fluoroalcohol group is derived from at least one ethylenically unsaturated compound containing a fluoroalcohol group having the structure:

-C(R_f)(R_f')OH

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wherein R_f and R_f are the same or different fluoroalkyl groups of from 1 to 10 carbon atoms or taken together are $(CF_2)_m$ wherein m is 2 to 10.

26. (Original) The photoresist composition of Claim 25, wherein R_f and R_f are perfluoroalkyl groups.

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27. (Currently amended) The photoresist composition of Claim 19, wherein the fluorine-containing polymer copolymer further comprises a fluoroalcohol group having the structure:

-XCH₂C(R_f)(R_f)OH

wherein Rf and Rf are the same or different fluoroalkyl groups of from 1 to 10 carbon atoms or taken together are (CF₂)_m wherein m is 2 to 10; and X is an element from Group VA and VIA of the Periodic Table of the Elements.

- 28. (Original) The photoresist composition of Claim 27, wherein X is selected from the group consisting of oxygen, sulfur, nitrogen and phosphorous.
- 29. (Original) The photoresist composition of Claim 28, wherein X is oxygen.
- 30. (Original) The photoresist composition of Claim 25, wherein the monomer containing the fluoroalcohol functional group or the protected 20 fluoroalcohol group is selected from the group consisting of:

$$\mathsf{CH_2C}(\mathsf{CF_3})_2\mathsf{OH} \qquad \mathsf{CH_2OCH_2C}(\mathsf{CF_3})_2\mathsf{OH}$$

$$\mathsf{CH_2C}(\mathsf{CF_3})_2\mathsf{OH} \qquad \mathsf{CH_2OCH_2C}(\mathsf{CF_3})_2\mathsf{OH}$$

CH2=CHO(CH2)4OCH2C(CF3)2OH CH2=CHOCH2CH2OCH2C(CF3)2OH

31. (Currently amended) The photoresist composition of Claim 19, wherein the fluorine-containing polymer copolymer further comprises at least one acid-containing or protected acid-containing group of structural unit:

$$(-CH_2-C_1 - C_2 - C_2 - C_2)$$

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wherein E₁ is H or C₁-C₁₂ alkyl; E₂ is CO₂E₃, SO₃E, or other acidic group; and E and E3 are independently selected from the group of H, unsubstituted C₁-C₁₂ alkyl, and heteroatom substituted C₁-C₁₂ alkyl.

- 32. (Original) The photoresist composition of Claim 31, wherein the 15 heteroatom is selected from the group consisting of oxygen, nitrogen, sulfur, halogen and phosphorus atoms.
- 33. (Original) The photoresist composition of Claim 32, wherein the heteroatom is oxygen, and the heteroatom substituted C1-C12 alkyl further 20 comprises a hydroxyl group.
- 34. (Original) The photoresist composition of Claim 31, wherein the acid-containing or protected acid-containing group is a carboxylic acidcontaining monomer. 25
 - 35. (Original) The photoresist composition of Claim 34, wherein the acid-containing or protected acid-containing group is selected from the

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group consisting of tert-butyl acrylate; 2-methyl-2-adamantyl acrylate; 2methyl-2-norbornyl acrylate and acrylic acid.

- 36. (Currently amended) The photoresist composition of Claim 19, wherein the fluorine-containing polymer copolymer further comprises at least one group derived from a polar monomer.
 - 37. (Original) The photoresist composition of Claim 19, wherein the photoactive component is a photoacid generator.
- 38. (Original) The photoresist composition of Claim 19, further comprising a dissolution inhibitor.
- 39. (Original) The photoresist composition of Claim 19, further comprising a solvent. 15
 - 40. (Original) The photoresist composition of Claim 39, wherein the solvent is selected from the group consisting of an ether ester, a ketone; an ester, a glycol ether, a substituted hydrocarbon; an aromatic hydrocarbon; a fluorinated solvent and super critical CO₂.
- 41. (Original) The photoresist composition of Claim 19, further comprising at least one additive selected from the group consisting of bases, surfactants, resolution enhancers, adhesion promoters, residue reducers, coating aids, plasticizers, and T_a (glass transition temperature) 25 modifiers.
 - (Currently amended) A coated substrate comprising:
 - (1) a substrate; and
 - (2) a photoresist composition comprising:
 - (a) a fluorine-containing polymer copolymer comprising a repeat unit derived from:

(i) at least one repeat unit derived from an ethylenically unsaturated compound having at least one fluorine atom covalently attached to an ethylenically unsaturated carbon atom; and (ii) at least one repeat unit derived from an ethylenically unsaturated compound having the structure:

$$\mathbb{R}^{1}$$

$$\mathbb{R}^{2}$$

$$\mathbb{R}^{3}$$
(1)

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and

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wherein n is 0, 1, or 2;

 R^{1} , R^{2} , R^{3} and R^{4} are independently H, OR^{5} , halogen, alkyl or alkoxy of 1 to 10 carbon atoms, optionally substituted by halogen or ether oxygens, Y, $C(R_{f})OR^{5}$, $R^{6}Y$ or $OR^{6}Y$;

Y is COZ or SO₂Z;

R5 is hydrogen or an acid-labile protecting group;

 R_f and R_f are the same or different fluoroalkyl groups of 1 to 10 carbon atoms or taken together are $(CF_2)_m$ where m is 2 to 10;

R⁶ is an alkylene group of 1 to 20 carbon atoms, optionally substituted by halogen or ether oxygen;

Z is OH, halogen, or OR7; and

 R^7 is an alkyl group of 1 to 20 carbon atoms, with the proviso that at least one of R^1 , R^2 , R^3 and R^4 is Y, OR^5 , $C(R_f)(R_f)OR^5$, R^6 Y or OR^6 Y, and the proviso that if R^1 (or R^3) is OH, R^2 (or R^4) is not OH or halogen;

(a) (b) a photoactive component.

43. (Original) The coated substrate of Claim 42, wherein the substrate is a microelectronic wafer.

- 44. (Original) The coated substrate of Claim 43, wherein the microelectronic wafer comprises a material selected from the group consisting of silicon, silicon oxide, silicon oxynitride, and silicon nitride.
- 45. (Original) A reaction product of quadracyclane and a fluoroalkylbenzoate compound.